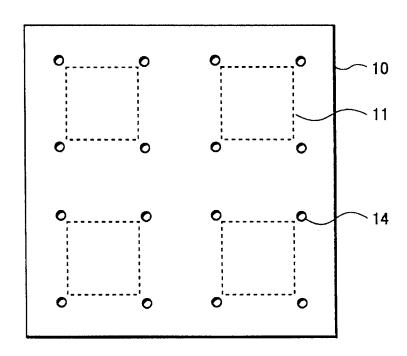
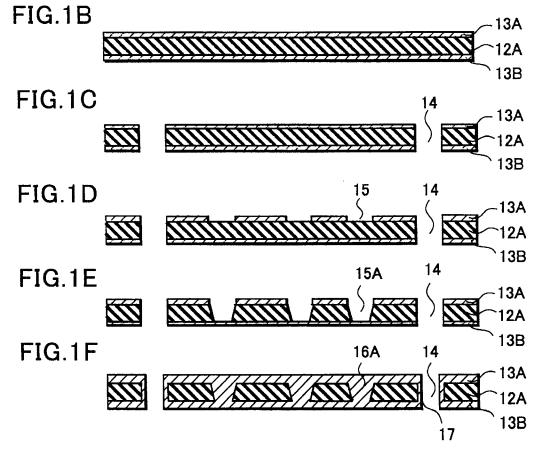
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FIG.1A



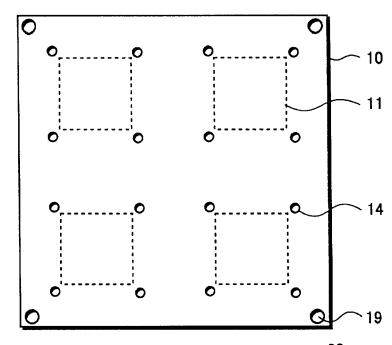


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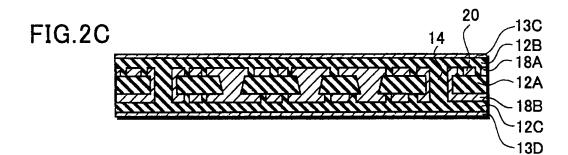
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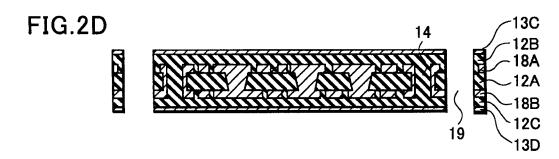
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FIG.2A



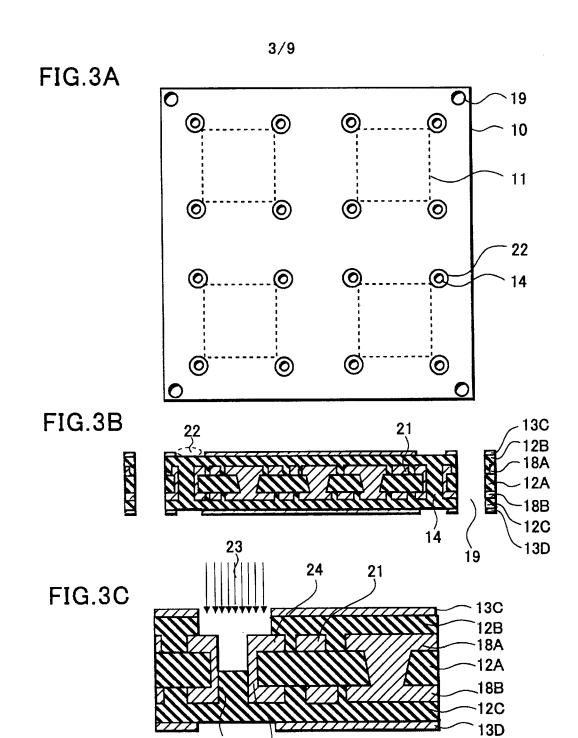


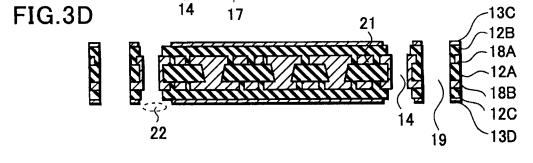




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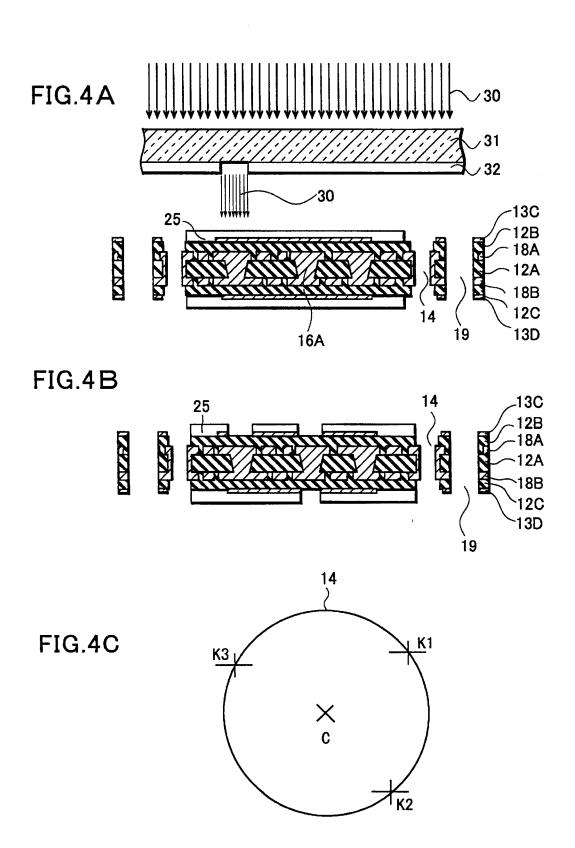
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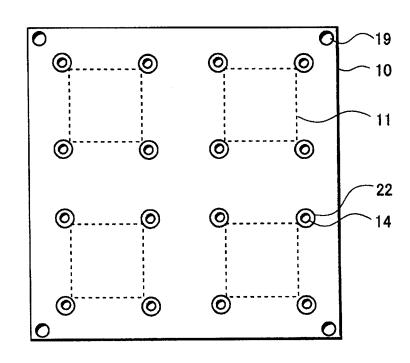
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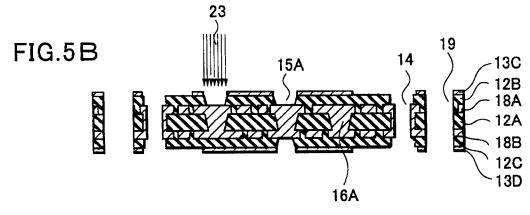
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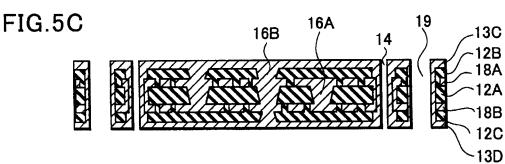


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FIG.5A

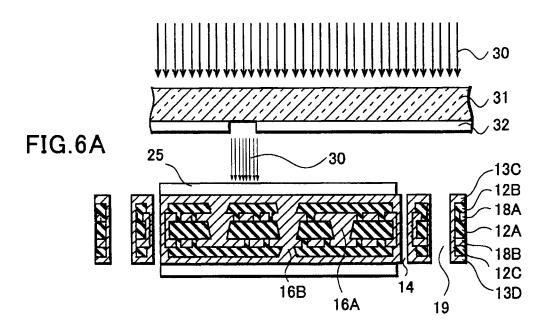


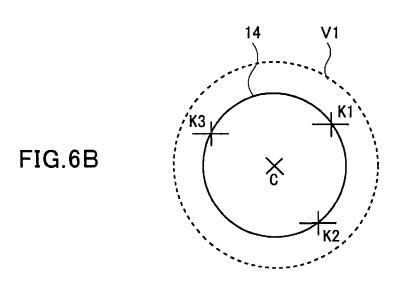




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FIG.7A

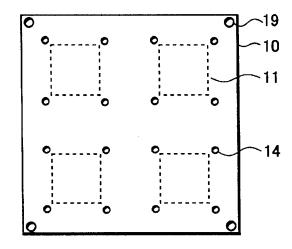


FIG.7B

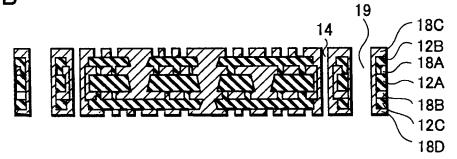
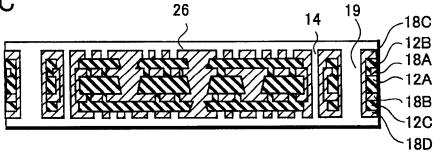
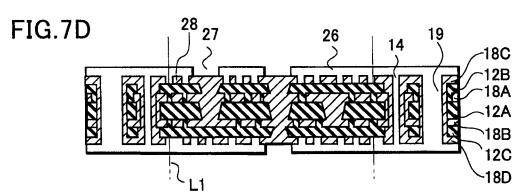


FIG.7C





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FIG.8A

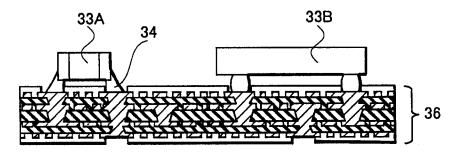
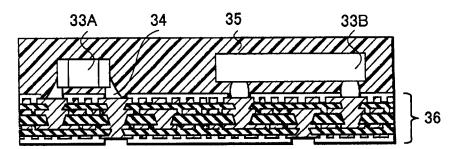


FIG.8B



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FIG.9A

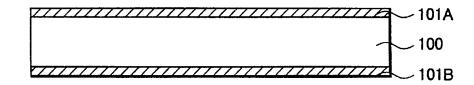


FIG.9B

